

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re application of: Ismail EMESH et al.                      Group Art Unit: 3723  
Serial No.:                      10/729,119                      Examiner:      Shakeri, Hadi  
Filed:                      December 4, 2003                      Confirmation No.: 3177  
For:                      LUBRICANT FOR WAFER POLISHING USING A FIXED  
                                 ABRASIVE PAD  
Attorney Docket No.: 004.0122

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**RESPONSE UNDER 37 C.F.R. § 1.116**

MAIL STOP AF  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is responsive to the final Office Action mailed on January 22, 2007. Please amend the above-identified application as set forth below.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.